

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

Claims 1-6 (Previously Canceled)

7. (Currently Amended) A memory cell, comprising:

a diffusive metal;

at least one floating gate;

a gate insulator including a first gate insulator layer disposed between the at least one floating gate and the diffusive metal, and a second gate insulator layer disposed below and coupled to the first gate insulator layer wherein the gate insulator includes a conductive path;

a channel region coupled to the gate insulator;

a source coupled to the channel region; and

a drain coupled to the channel region, ~~wherein the diffusive metal is responsive to a write voltage to diffuse conductive elements through the gate insulator ; and~~

wherein the first gate insulator layer includes a conductive path formed by the diffusion of conductive elements from the diffusive metal through the gate insulator in response to a write voltage applied to the diffusive metal, and the at least one floating gate adapted to prevent the conductive elements from the diffusive metal from diffusing into the second gate insulator layer.

8. (Original) The memory cell of claim 7, wherein the channel region, the source, and the drain are parts of a continuous layer of semiconductor material.

9. (Original) The memory cell of claim 8, wherein the source and drain are doped regions of the layer of semiconductor material.

10. (Canceled).

11. (Currently Amended) The memory cell of claim ~~10~~ 7, wherein the diffusive metal is a gate electrode.

12. (Currently Amended) The memory cell of claim 7, wherein the at least one floating gate comprises a plurality of floating gates, and wherein the gate insulator comprises a plurality of gate insulator layers extending between the floating gates.

13. (Currently Amended) A memory array, comprising:
a substrate;
a plurality of gate lines disposed over the substrate;
a plurality of data lines crossing the gate lines and disposed over the substrate; and
a plurality of memory cells at crossing points of the gate lines and data lines, each memory cell being coupled to a gate line and a data line that cross at the memory cell, wherein a memory cell comprises:
a diffusive metal;
at least one floating gate;
a gate insulator including a first gate insulator layer disposed between the at least one floating gate and the diffusive metal, and a second gate insulator layer disposed below

and coupled to the first gate insulator layer wherein the gate insulator includes a conductive path;

a channel region coupled to the gate insulator;

a source coupled to the channel region; and

a drain coupled to the channel region, ~~wherein the diffusive metal is responsive to a write voltage to diffuse conductive elements through the gate insulator ; and~~

wherein the first gate insulator layer includes a conductive path formed by the diffusion of conductive elements from the diffusive metal through the gate insulator in response to a write voltage applied to the diffusive metal, and the at least one floating gate adapted to prevent the conductive elements from the diffusive metal from diffusing into the second gate insulator layer.

14. (Original) The memory array of claim 13, wherein the data lines comprise strips of semiconductor material, the sources and the drains comprising doped regions of the data lines.

15. (Original) The memory array of claim 13, wherein the gate insulator extends between the diffusive metal and the floating gate, and between the floating gate and the channel region.

16. (Original) The memory array of claim 13, wherein the gate lines are conductive lines coupled to the memory cells, the diffusive metal comprising a part of a gate line.

17. (Original) The memory array of claim 13, wherein the at least one floating gate comprises a plurality of floating gates, the gate insulator extending between the floating gates.

18. (Original) The memory array of claim 13, wherein the gate lines comprise: a first conductor disposed over the gate insulator; and a second conductor coupled to the first conductor.

19. (Original) The memory array of claim 18, wherein the first conductor includes a diffusive metal disposed between the insulator and the second conductor.

20. (Original) The memory array of claim 13, wherein the substrate comprises at least one of a glass or a plastic.

Claims 21-25 (Previously Canceled)

26. (Currently Amended) A memory cell, comprising:

a diffusive metal;

at least one floating gate;

a gate insulator disposed between the at least one floating gate and the diffusive metal,

wherein the gate insulator comprises a low temperature oxide and a conductive path formed from conductive elements from ~~includes a portion of~~ the diffusive metal diffused through the gate insulator in response to a write voltage applied to the diffusive metal;

a channel region coupled to the gate insulator;

a source coupled to the channel region; and
a drain coupled to the channel region, ~~wherein the diffusive metal is responsive to a write voltage to diffuse conductive elements through the gate insulator.~~

27. (Previously Added) The memory cell of claim 26, wherein the channel region, the source, and the drain are parts of a continuous layer of semiconductor material.

28. (Previously Added) The memory cell of claim 27, wherein the source and drain are doped regions of the layer of semiconductor material.

29. (Previously Added) The memory cell of claim 26, wherein the gate insulator extends between the diffusive metal and the floating gate, and between the floating gate and the channel region.

30. (Previously Added) The memory cell of claim 29, wherein the diffusive metal is a gate electrode.

31. (Previously Added) The memory cell of claim 26, wherein the at least one floating gate comprises a plurality of floating gates, the gate insulator extending between the floating gates.

32. (Added) The memory cell of claim 1, wherein specification, the at least one floating gate comprises a metal selected from the group consisting of W, Al, Cr, TiW, and Cu.